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MAY 2 1 2001 APPLICATION NO: ATTY. DOCKET NO: S. DEPARTMENT OF COMMERCE Form PTO-1449 09/813,548 72545-28 PATENT AND TRADEMARK OFFICE (Rev. 8-83) OIPE APPLICANTS: Richard E. Gahan and Wei Ming Choi INFORMATION DISCLOSURE CITATION GROUP ART UNIT: FILING DATE: MAY 2 2 2001 Not Yet Assigned March 21, 2001 (Use several sheets if necessary) **U.S. PATENT DOCUMENTS** EXAMINERHADEN SUBCLASS FILING DATE IF DOCUMENT NUMBER DATE NAME CLASS APPROPRIATE* INITIAL FOREIGN PATENT DOCUMENTS TRANSLATION DOCUMENT NUMBER DATE COUNTRY CLASS SUBCLASS YES NO OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.) Golub, M.A. et al., "On the Similarity of Plasma-polymerized Tetrafluoroethylene and RF Plasma-sputtered MAY Polytetrafluoroethylene," Abstracts of Papers of the American Chemical Society, vol. 214, no. 2, 668-9 (Sept. 7, 1997); Klausner, M. et al., "Surface Modification of Polymers with Fluorine Containing Plasmas: Deposition vs. CG Replacement Reactions," Poly. Mater. Sci. & Eng., vol. 56, 227-31 (1987); Labelle, C.B. and Gleason, K.K., "Pulsed Plasma Enhanced Chemical Vapor Deposition from C2H2F4, CH2F2, and CH CHCLF2," Polymer Preprints, vol. 39, no. 2, 928-9 (Aug. 1998); Lau, K.K.S. and Gleason, K.K., "High Resolution 19F MAS NMR Spectroscopy of Pulsed Plasma-Polymerized Fluorocarbon Films," Polymer Preprints, vol. 39, no. 2, 936-7 (Aug. 1998); Loh, I.H., "Surface Modifications of Polymers with Fluorine-Containing Plasmas: Deposition Versus Replacement CJ Reactions," Polymer Engineering and Science, vol. 27, no. 11, 861-8 (June, 1987); Luginbuehl, R. et al., "Surface Chemistry and Elastic Properties of Plasma Deposited Fluoropolymers," Polymer CK Preprints, vol. 39, no. 2, 932-3 (Aug. 1998); "Innovative Turnkey Coating and Surface Treatment Systems," Sigma Technologies Intl. Inc. Bulletin 3000; CL Silverstein, M.S. and Chen, R., "Effect of Monomer Composition on the Structure and Properties of Plasma CM Fluoropolymers," Polymer Preprints, vol. 38, no. 1, 1025-6 (April 1997); Vargo, T.G. and Koloski, T.S., "Highly Adherent Metallization via Direct Covalent Bonding of Transition Metals to CN Plasma Modified Fluoropolymers," Proc. Annu. Meet. Adhes. Soc., vol. 22, 86-7 (1999); Examiner Date Considered: *EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and considered. Include copy of this found with next communication to applicant. 984242 1

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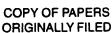
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